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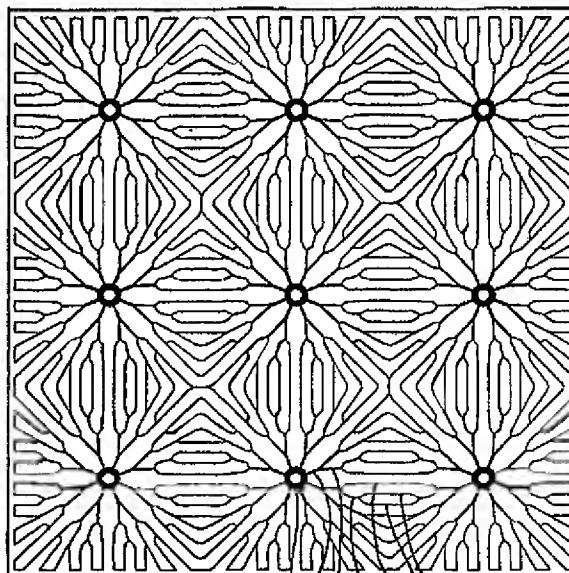
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(54) Title: METHOD FOR OPTIMIZING A METALLIZATION PATTERN ON A PHOTOVOLTAIC CELL

(57) Abstract

Method for applying a metallization in accordance with a pattern of a system of mutually connected electrical conductors for transporting electrical charge carriers on at least one of the outer surfaces of a photovoltaic element, wherein the conductors display a determined series resistance and cover a part of the at least one surface in accordance with a determined degree of covering, which method comprises the steps of (i) providing said photovoltaic element, at least one of the outer surfaces of which is adapted for applying of a metallization thereto, and (ii) applying a metallization in accordance with a determined pattern on the relevant surface, wherein the metallization is applied in the second step (ii) in accordance with an optimized pattern, the geometry of which is defined such that the electrical power of this element is maximal as a function of this geometry, and photovoltaic element provided with a metallization applied according to this method.



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METHOD FOR OPTIMIZING A METALLIZATION PATTERN ON A PHOTOVOLTAIC CELL

The invention relates to a method for applying a metallization in accordance with a pattern of a system of mutually connected electrical conductors for transporting electrical charge carriers on at least one of the outer surfaces of a photovoltaic element, wherein the conductors display a determined series resistance and cover a determined fraction of at least the one surface, which method comprises the steps of

(i) providing said photovoltaic element, at least one of the outer surfaces of which is adapted for applying of a metallization thereto, and

(ii) applying a metallization in accordance with a determined pattern on the relevant surface.

A photovoltaic element (solar cell) generally comprises a stacked structure of at least one layer of semiconductor material of the p-type and a layer of semiconductor material of the n-type for generating electrical charge carriers under the influence of photons incident on the interface of these layers; a pattern of a system of mutually connected conductors, hereinafter referred to as metallization pattern, forms an essential part of such an element. A metallization pattern is usually applied to the front and rear surface of a solar cell, for instance using screen-printing techniques, in order to make electrical contacts with this cell. Applied metallization is usually non-transparent and causes shadow losses in a solar cell on the side receiving the sunlight (further designated as front side).

The design of a metallization pattern applied by means of screen-printing to the front side of a solar cell is generally the result of a compromise between shadow losses caused by this metallization and the electrical series resistance of the metallization pattern: the lower

the resistance, the greater the total surface area of the pattern and the shadow losses caused thereby. On the rear side of a solar cell shadow losses generally do not represent a problem, completely covering the rear side with a metallization layer is however not strictly necessary for proper functioning of a solar cell, while the production costs of such a full layer are generally higher than those of a metallization pattern which does not completely cover the rear side.

10 A metallization pattern usually comprises a web of thin lines, referred to as fingers. These lines have to be thin so that they can be arranged close to each other in order to thus reduce losses resulting from the resistance in the material of the photovoltaic element (the emitter resistance). The fingers themselves generally have insufficient electrical conductivity to conduct a photo current to the edge of the photovoltaic element without considerable losses. In order to reduce losses in the fingers, contact strips, so-called tabs, are usually arranged over the fingers which increase the total conductivity and also serve to connect a solar cell to another solar cell.

A web of fingers can in principle have any topology and dimensions, so that it is particularly difficult to find a generally optimal pattern. Optimizing of a metallization pattern therefore generally takes place for a group of patterns within a determined topology. Known is a method for optimizing the finger distance in an H-shaped metallization mesh assembled from parallel fingers and tabs extending transversely thereover. The direction of the fingers is fixed by the choice of this special pattern and is not chosen optimally. Another drawback of the known optimization method is that it is limited to solar cells with a particular, generally rectangular geometry.

35 The object of the invention is to provide a method for applying a metallization pattern optimized for resistance losses and shadow losses, irrespective of the

geometry of the relevant photovoltaic element.

This object is achieved, and other advantages gained, with a method of the type stated in the preamble, wherein according to the invention the metallization is applied in
5 the second step (ii) in accordance with an optimized pattern, the geometry of which is defined such that the electrical power of this element is maximal as a function of this geometry.

The invention is based on the surprising insight that
10 it is possible to express a known metallization pattern of a system of mutually connected electrical conductors on a solar cell in an at least partially transparent metallization which completely covers this solar cell, wherein the same shadow and resistance losses occur as in
15 this known metallization pattern.

It has now been found that it is conversely possible to construct a system of mutually connected electrical conductors from an at least partially transparent metallization which completely covers a solar cell,
20 wherein the same shadow and resistance losses occur as in this at least partially transparent metallization.

In an embodiment of the method according to the invention the optimized pattern for the purpose of applying a metallization pattern causing shadow and
25 resistance losses on a front surface of the photovoltaic element adapted to receive incident light is obtained by determining the thickness as a function of the location, and therefore determining the progression of the thickness, on said front surface of a light-transmitting
30 metallization layer which completely covers this front surface and allows through a fraction of a quantity of incident light corresponding with said degree of covering, in a manner such that the sum of the shadow and resistance losses which would occur in this element in operative
35 state is minimal and deriving from this thickness as a function of location the geometry of a pattern of a system

of mutually connected non-light-transmitting electrical conductors.

In another embodiment of the method according to the invention the optimized pattern for the purpose of
5 applying a metallization pattern causing resistance losses on a rear surface of the photovoltaic element lying opposite a front surface adapted to receive incident light is obtained by determining the thickness as a function of the location on said rear surface of a light-transmitting
10 metallization layer which completely covers this rear surface and allows through a fraction of a quantity of incident light corresponding with said degree of covering in a manner such that the sum of the resistance losses and a measure expressed in loss of efficiency for the quantity
15 of material for the metallization which would occur in this element in operative state is minimal, and deriving from this thickness as a function of the location the geometry of a pattern of a system of mutually connected non-light-transmitting electrical conductors.

20 In an embodiment of a method according to the invention the thickness as a function of the location of the respective metallization layer is generally determined for a case in which the metallization layer which would completely cover the respective surface has an isotropic
25 electrical conductivity.

In a particular case, for instance when optimizing a metallization pattern with a pattern of lines which conducts the electrical current generated in the relevant solar cell in a determined direction, the thickness as a
30 function of the location of the respective metallization is determined for a case in which the metallization layer which would completely cover the respective surface has an anisotropic electrical conductivity.

In a following embodiment of the method the optimized
35 pattern is obtained by determining the thickness of the respective light-transmitting metallization layer as a function of the location on the respective surface, in a

manner such that the electrical power of this element is also maximal as a function of the electrical resistance in the transition between the surface of the element and the metallization.

5 In yet another embodiment the optimized pattern is obtained by determining the thickness of the respective light-transmitting metallization layer as a function of the location on the respective surface, in a manner such that the electrical power of this element is also maximal
10 as a function of the surface resistance of the element.

In yet another following embodiment the optimized pattern is obtained by determining the thickness of the respective light-transmitting metallization layer as a function of the location on the respective surface, in a
15 manner such that the electrical power of this element is also maximal as a function of the resistivity of the material of the metallization.

Determining of the thickness of the metallization for a number of points distributed over a front surface in a
20 manner such that the sum of the occurring shadow and resistance losses which would occur in this element in operative state in the presence of a metallization layer completely covering this front surface is minimal, is for instance performed as follows.

25 If in a point represented by coordinates (x, y) , on the surface of the front side of a photovoltaic element the local current density and the voltage at the maximum power generated by this element are represented by respectively J_{mp} and V_{mp} , the total generated power P_g in
30 the absence of shadow losses caused by a metallization layer is then given by the equation

$$P_g = \int_S J_{mp} V_{mp} dx dy \quad (1)$$

35 in which S is the surface of the element.

The maximum power represented by equation (1) is in practice lower as a result of the occurring shadow and resistance losses. On the front side of the element the current density is reduced as a result of shadow effects
 5 caused by the necessarily present metallization:

$$J'_{mp}(x, y) = J_{mp}(1 - p_s(x, y)) \quad (2)$$

in which $p_s(x, y)$ represents the shadow fraction which is
 10 given by

$$p_s(x, y) = \frac{d(x, y)}{d_0} \quad (3)$$

in which $d(x, y)$ is the thickness as a function of the
 15 location of an at least partially transparent metallization layer and d_0 the thickness of a conductor in a system of mutually connected conductors.

From $p_s(x, y)$ a location-dependent effective surface resistance $\rho_{sm}(x, y)$ can be determined:
 20

$$\rho_{sm}(x, y) = \frac{\rho_{sm,0}}{p_s(x, y)} \quad (4)$$

in which $\rho_{sm,0}$ is the surface resistance of the lines forming the metallization pattern.

The ohmic losses in the metallization are determined
 25 by solving a partial differential equation for the voltage distribution $V(x, y)$:

$$\vec{\nabla} \cdot \left(\frac{1}{\rho_{sm}(x, y)} \vec{\nabla} V(x, y) \right) = -J'_{mp}(x, y) \quad (5)$$

30 The pattern of the electrical currents resulting from the solution of this differential equation (5) is the pattern in which the least ohmic dissipation occurs. The differential equation must be solved with boundary

conditions, given by the voltage on the connection points for external contacts of the relevant solar cell.

Equation (5) enables calculation of the voltage distribution $V(x,y)$ and the direction of the current density in the metallization, from the geometry of the solar cell, the surface resistance $\rho_{sm}(x,y)$ and the local current density $J'_{mp}(x,y)$. The power dissipated in the metallization is given by:

$$P_m = \int_S \frac{1}{\rho_{sm}(x,y)} (\nabla V(x,y))^2 dx dy \quad (6)$$

Ohmic losses likewise occur in the transition between element surface (the emitter) and the metallization. The contact between emitter and metallization is represented by an effective contact resistance ρ_{ce} which depends on the finger width of the relevant metallization and the surface resistance under the emitter. The power dissipated as a result of the contact resistance is represented by:

$$P_c = \rho_{ce} \int_S \frac{J'_{mp}(x,y)^2}{p_s(x,y)} dx dy \quad (7)$$

in which $p_s(x,y)$ represents a reduction factor of the contact surface which is a result of partial metallization.

A further cause of ohmic losses is formed by the emitter surface resistance, ρ_e . It can be derived that the power P_e per unit of area dissipated as a result hereof for a metallization pattern of parallel fingers with a width w is given by:

$$P_e = \int_S \frac{w^2}{12} \left(\frac{1 - p_s(x,y)}{p_s(x,y)^2} \right) \rho_e J'_{mp}(x,y)^2 dx dy \quad (8)$$

No power is of course generated in the part of the surface of a solar cell covered by the metallization pattern. The quantity of power not generated as a result

of covering the solar cell surface, referred to as the shadow loss P_s , is represented by:

$$P_s = \int_S P_s(x, y) J_{mp} V_{mp} dx dy \quad (9)$$

5 Shadow losses generally play no significant part on the rear side of a solar cell. It is however important to limit the quantity of material for a metallization layer on the rear side. It can be derived that a quantity of material to be optimized can be expressed in terms of a shadow loss, as follows:

$$P_s = \int_S P_s(x, y) J_{mp} V_{mp} F_c dx dy \quad (10)$$

F_c is here a dimensionless parameter which relates the quantity of material to an efficiency loss.

15 The total loss of power P_t occurring in a solar cell can thus be expressed in terms of a shadow loss and occurring ohmic losses:

$$P_t = P_s + P_m + P_c + P_o \quad (11)$$

20 According to the invention an optimal location-dependent shadow fraction $p_s(x, y)$ is determined. Losses P_c and P_o respectively resulting from occurring contact resistance and emitter surface resistance as well as the shadow loss P_s follow directly from this shadow fraction using equations (7) and (8). From the shadow fraction the surface resistance $\rho_{sm}(x, y)$ can be calculated using equation (4), and the current density J'_{mp} can be calculated using equation (2). The partial differential equation (5) can be solved using the surface resistance $\rho_{sm}(x, y)$. Once this equation is solved, the ohmic losses in the metallization can be determined. The shadow fraction $p_s(x, y)$ must be chosen such that the total loss P_t is minimal.

The optimization is performed as follows. A main program, written in C, addresses a subroutine written in Fortran which finds a local optimum of a continuous and differentiable function of a number of parameters which
 5 can be freely chosen. The subroutine has upper and lower limits for the parameters. The parameters are the shadow fractions $p_s(x_i, y_i)$ at a set of points (x_i, y_i) to be defined by the user, designated hereinafter as coarse mesh.

The function is in this case a relatively complicated
 10 construction which calculates the total loss P_t from the shadow fractions on the relevant coarse mesh. For a random point (x, y) , $p_s(x, y)$ is defined by means of interpolation from the values $p_s(x_i, y_i)$. The partial differential equation (5) is solved with a finite element method (FEM).

15 The integrands for the contact resistance loss (7), the emitter surface resistance loss (8) and the generated power are evaluated on the fine-mesh network of the finite element method, wherein for each integrand an interpolant is created which is then integrated.

20 Once the optimal shadow fraction $p_s(x, y)$ is determined, a translation can be performed to an equivalent metallization pattern. The orientation of the fingers is given by the field strength $\bar{V}(x, y)$. The average shadow fraction can be translated to a position-
 25 dependent finger distance $s(x, y)$:

$$s(x, y) = \frac{W}{P_s(x, y)} \quad (12)$$

It has been found that in a solar cell provided with a screen-printed metallization pattern according to the
 30 invention, the metallization losses, which amount to about 12 to 13% in a pattern according to the prior art, are reduced to about 7%.

The invention will be elucidated hereinbelow on the basis of embodiments and with reference to the annexed
 35 drawings.

In the drawings

Fig. 1 shows in top view a square solar cell according to the prior art, provided with an H-shaped metallization mesh, with parallel fingers and two tabs extending transversely thereover,

5 Fig. 2 shows in top view a square solar cell provided with a metallization mesh which is obtained according to a first embodiment of the method according to the invention by optimizing the H-shaped metallization mesh shown in fig. 1,

10 Fig. 3 shows in top view a detail of the surface of the solar cell of fig. 2, in which are drawn calculated normalized current density vectors and contour lines representing the calculated percentage of coverage by the metallization lines,

15 Fig. 4 shows in bottom view a square solar cell provided with a metallization mesh which is obtained according to a second embodiment of the method according to the invention by optimizing a metallization mesh covering the entire rear side of the solar cell,

20 Fig. 5 shows in bottom view the surface of the solar cell of fig. 4, in which are drawn calculated normalized current density vectors and contour lines representing the calculated percentage of coverage by the metallization lines,

25 Fig. 6 shows in top view a first embodiment of a square solar cell of the MRT ('metallization wrap through') type, provided with a metallization mesh as shown in fig. 7 and obtained according to a third embodiment of the method according to the invention by
30 starting when optimizing from a metallization mesh covering the whole top or front side of the solar cell,

Fig. 7 shows a top view of a detail of the solar cell shown in fig. 6 with the metallization mesh,

35 Fig. 8 shows in top view a further enlarged detail of the solar cell shown in fig. 6 with the metallization mesh,

Fig. 9 shows in top view a detail of the surface of the solar cell of fig. 6, in which are drawn calculated normalized current density vectors and contour lines representing the calculated percentage of coverage by the metallization lines, and

Fig. 10 shows in top view a second embodiment of a square solar cell of the MRT ('metallization wrap through') type, provided with a metallization mesh which according to a third embodiment of the method according to the invention is obtained by starting when optimizing from a metallization mesh covering the whole top or front side of the solar cell.

Fig. 1 shows the front side, adapted to receive incident sunlight, of a square crystalline silicon solar cell 1 according to the prior art (dimensions $12.5 \times 12.5 \text{ cm}^2$) with an H-shaped metallization pattern of parallel fingers 2 which are applied according to a known screen-printing technique and contact strips (tabs) 3, which have a higher conductivity than the fingers. Further shown is a coordinate system (x, y).

Fig. 2 shows the front side, adapted to receive incident sunlight, of an embodiment of a square crystalline silicon solar cell 10 according to the invention (dimensions $12.5 \times 12.5 \text{ cm}^2$), provided with tabs 3 and a metallization mesh 6, 7. The density of the fingers 6 increases in the direction of the current take-off points on the left-hand side. For the mutual contact of fingers in regions of different density use is made of connecting strips 7 which extend along paths of equivalent potential. Connecting strips 7 provide the added advantage that the adverse effect of a fracture in an individual finger 6 on the efficiency of the solar cell is reduced, since in the case of a fracture a part of finger 6 will always remain in connection with the respective tab 3. Fingers 6 are applied in a pattern which takes as starting point the pattern of solar cell 1 shown in fig. 1 but for

which according to the invention the power losses are optimized for the shadow fraction caused by the fingers.

Because the fingers in the H-shaped metallization pattern of fig. 1 only conduct in y-direction, equation
 5 (5) must be generalized in the optimization procedure as follows, in order to enable anisotropic conductivity:

$$\frac{\delta}{\delta x} \left(\frac{1}{\rho_x(x, y)} \frac{\delta V(x, y)}{\delta x} \right) + \frac{\delta}{\delta y} \left(\frac{1}{\rho_y(x, y)} \frac{\delta V(x, y)}{\delta y} \right) = J'_{mp}(x, y) \quad (13)$$

10 wherein the current density vector is given by:

$$\vec{J}(x, y) = \begin{pmatrix} \frac{1}{\rho_x(x, y)} \frac{\delta V(x, y)}{\delta x} \\ \frac{1}{\rho_y(x, y)} \frac{\delta V(x, y)}{\delta y} \end{pmatrix} \quad (14)$$

The best conductivity in a random direction can then be modelled by including the second mixed derived term

15 $\frac{\delta}{\delta x} \left(\frac{1}{\rho_{xy}(x, y)} \frac{\delta V(x, y)}{\delta y} \right)$ in the calculation. In this way the

anisotropic conductivity is used to analyze other metallization patterns with fingers extending in random directions, by bringing the anisotropic conductivity into line with the fingers.

20 The tab ($y > y_0$) has a surface conductivity σ_t . For ($y < y_0$) the conductivity σ_x is set to zero in x-direction and $\rho_y = \frac{s}{W} \rho_{sm, 0}$ applies.

In this case the conductivity of the metallization pattern is determined by only one parameter, the finger
 25 distance s , which is found by optimizing the power produced by the cell.

Fig. 3 shows the lower part of the surface of solar cell 10 of fig. 2, which for the purpose of the calculations is deemed a unit cell, in which are drawn

calculated normalized current density vectors $\vec{j}(x,y)/j|(x,y)|$ and contour lines 5 representing the calculated percentage of coverage by the metallization lines.

5 Comparison of fig. 1 and fig. 2 and 3 teaches that the optimized metallization pattern in solar cell 10 differs only slightly from the H-shaped metallization pattern with non-tapering fingers in solar cell 1 of fig. 1. In the optimized cell the direction of the current is also substantially perpendicular to that of the tabs 3. The resistance of tabs 3 is low compared to that of the metallization, so that resistance losses in the metallization are minimal when the current flows along the shortest route to tabs 3. In the optimized unit cell the 15 metallization is shifted slightly in the direction of the edge of the unit cell to the region close to tab 3.

Fig. 4 shows the rear side of a solar cell 20 provided with a metallization mesh 6, 7 which is obtained according to the invention by starting when optimizing 20 from a metallization mesh which covers the entire rear side of the solar cell. The density of fingers 6 increases in the direction of the current take-off points on the left-hand side. For the mutual contact of fingers in regions of different density use is made of connecting 25 strips 7 extending along paths with equivalent potential. By way of alternative, it is possible to choose a pattern with a branching structure, according to which structure the fingers 4 do not extend fully parallel to the pattern with maximum current densities. The shown pattern results 30 in a coverage by the metallization of 24% of the rear side of the solar cell, corresponding to a value $F_c = 0.03$ for the dimensionless parameter in equation (9).

Fig. 5 shows the lower part of the surface of solar cell 20 of fig. 4, in which are drawn calculated 35 normalized current density vectors $\vec{j}(x,y)/j|(x,y)|$ and contour lines 5 representing the calculated percentage of coverage by the metallization lines.

Fig. 6 shows the front side, adapted to receive incident sunlight, of a square solar cell 30 of $12.5 \times 12.5 \text{ cm}^2$ of the MRT ('metallization wrap through') type with nine holes 8 with a diameter of 2 mm. In an MRT solar cell the negative and positive contacts are both situated on the rear side of the cell, in order to reduce shadow losses on the front side, wherein use is made of passages in the solar cell surface for through-feed of conductors. The shown solar cell 30 can be subdivided into nine identical square physical unit cells, which can each be subdivided into eight mathematical unit cells.

Fig. 7 shows in detail a physical unit cell PQRS of MRT solar cell 30 of fig. 6 with a metallization pattern 11, 12, 13, 14, 15 obtained according to a method wherein it was deemed a full metallization of varying thickness. The average shadow fraction or light-transmitting metallization of the pattern consists of a linear combination of the analytic function μ/r and an interpolant which is based on six points of the mathematical unit cell 9. In the function μ/r , r is the distance from the centre of hole 8 to a point on the unit cell PQRS and μ is a scalar quantity, the value of which is determined by fittings. The width of the fingers decreases at each branching in the direction from hole 8 toward the edges of the unit cell PQRS: in the example the drawn fingers 11, 12, 13 have a line width of respectively 300, 150 and 100 μm .

Fig. 8 shows in detail a mathematical unit cell 9 of the MRT solar cell 30 of fig. 6, corresponding with the sector of fig. 9 which is bounded by the periphery of hole 8, the point T in the centre of the line segment QR and the point R.

Fig. 9 shows the surface of the mathematical unit cell 9 of solar cell 30 of fig. 6, in which are drawn calculated normalized current density vectors $\vec{j}(x,y)/|j|(x,y)|$ and contour lines 5 representing the calculated percentage of coverage by the metallization

lines. The figure shows that the shadow fraction increases markedly close to a hole 8. Emitter and contact resistances are dominant in the part of unit cell 9 furthest removed from hole 8, which results in a constant value for the shadow fraction of about 5%. The more holes a solar cell comprises per unit of area, the lower the contribution of line resistance becomes. Because losses resulting from emitter and contact resistances are constant, they will begin to dominate as the number of holes increases further so that the number of holes per unit area has an upper limit which, in the case of the present solar cell with a surface area of $12.5 \times 12.5 \text{ cm}^2$, amounts to about 25.

Fig. 10 shows the front side, adapted to receive incident sunlight, of a square solar cell 40 of the MRT type, which is an alternative embodiment of the solar cell 30 shown in fig. 6. In solar cell 30 a connection between fingers 13 and 15 at different mutual distance is made using continuous lines 14 closed in peripheral direction. In solar cell 40 the fingers 13, 15 are branched per physical unit cell in a manner such that they lie in line with corresponding fingers in an adjacent unit cell, and the lines 14 closed in peripheral direction are omitted.

It is noted that above embodiments serve to elucidate the invention, which can in principle be applied in optimizing a metallization pattern on any type of solar cell, wherein it is not required to specify the direction of the current in this solar cell or the topology of the metallization. With the method according to the invention the metallization pattern can for instance be optimized for a maximum efficiency at a determined level of incident sunlight, for a maximum annual energy yield, or for an optimal balance between the cost of a metallization pattern and the electrical resistance of that pattern.

CLAIMS

1. Method for applying a metallization in accordance with a pattern of a system of mutually connected electrical conductors for transporting electrical charge carriers on at least one of the outer surfaces of a photovoltaic element, wherein the conductors display a determined series resistance and cover a part of the at least one surface in accordance with a determined degree of covering, which method comprises the steps of
- (i) providing said photovoltaic element, at least one of the outer surfaces of which is adapted for applying of a metallization thereto, and
- (ii) applying a metallization in accordance with a determined pattern on the relevant surface, characterized in that
- the metallization is applied in the second step (ii) in accordance with an optimized pattern, the geometry of which is defined such that the electrical power of this element is maximal as a function of this geometry.
2. Method as claimed in claim 1 for applying a metallization pattern causing shadow and resistance losses on a front surface of the photovoltaic element adapted to receive incident light, characterized in that the optimized pattern is obtained by determining the thickness as a function of the location on said front surface of a light-transmitting metallization layer which completely covers this front surface and allows through a fraction of a quantity of incident light corresponding with said degree of covering, in a manner such that the sum of the shadow and resistance losses which would occur in this element in operative state is minimal, and by deriving from this thickness as a function of the location the geometry of a pattern of a system of mutually connected electrical conductors.
3. Method as claimed in claim 1 for applying a

metallization pattern causing resistance losses on a rear surface of the photovoltaic element lying opposite a front surface adapted to receive incident light, characterized in that the optimized pattern is obtained by determining
5 the thickness as a function of the location on said rear surface of a light-transmitting metallization layer which completely covers this rear surface and allows through a fraction of a quantity of incident light corresponding with said degree of covering, in a manner such that the
10 sum of the resistance losses and a measure expressed in loss of efficiency for the quantity of material for the metallization which would occur in this element in operative state is minimal, and by deriving from this thickness as a function of the location the geometry of a
15 pattern of a system of mutually connected electrical conductors.

4. Method as claimed in claim 2 or 3, characterized in that the thickness as a function of the location of the respective metallization layer is determined for a case in
20 which the metallization layer which would completely cover the respective surface has an isotropic electrical conductivity.

5. Method as claimed in any of the claims 2-4, characterized in that the optimized pattern is obtained by
25 determining the thickness of the respective light-transmitting metallization layer as a function of the location on the respective surface, in a manner such that the electrical power of this element is also maximal as a function of the electrical resistance in the transition
30 between the surface of the element and the metallization.

6. Method as claimed in any of the claims 2-5, characterized in that the optimized pattern is obtained by determining the thickness of the respective light-transmitting metallization layer as a function of the
35 location on the respective surface, in a manner such that the electrical power of this element is also maximal as a function of the surface resistance of the element.

7. Method as claimed in any of the claims 2-6,
characterized in that the optimized pattern is obtained by
determining the thickness of the respective light-
transmitting metallization layer as a function of the
5 location on the respective surface, in a manner such that
the electrical power of this element is also maximal as a
function of the resistivity of the material of the
metallization.

8. Photovoltaic element provided with a metallization
10 applied according to a method as claimed in any of the
claims 1-7.

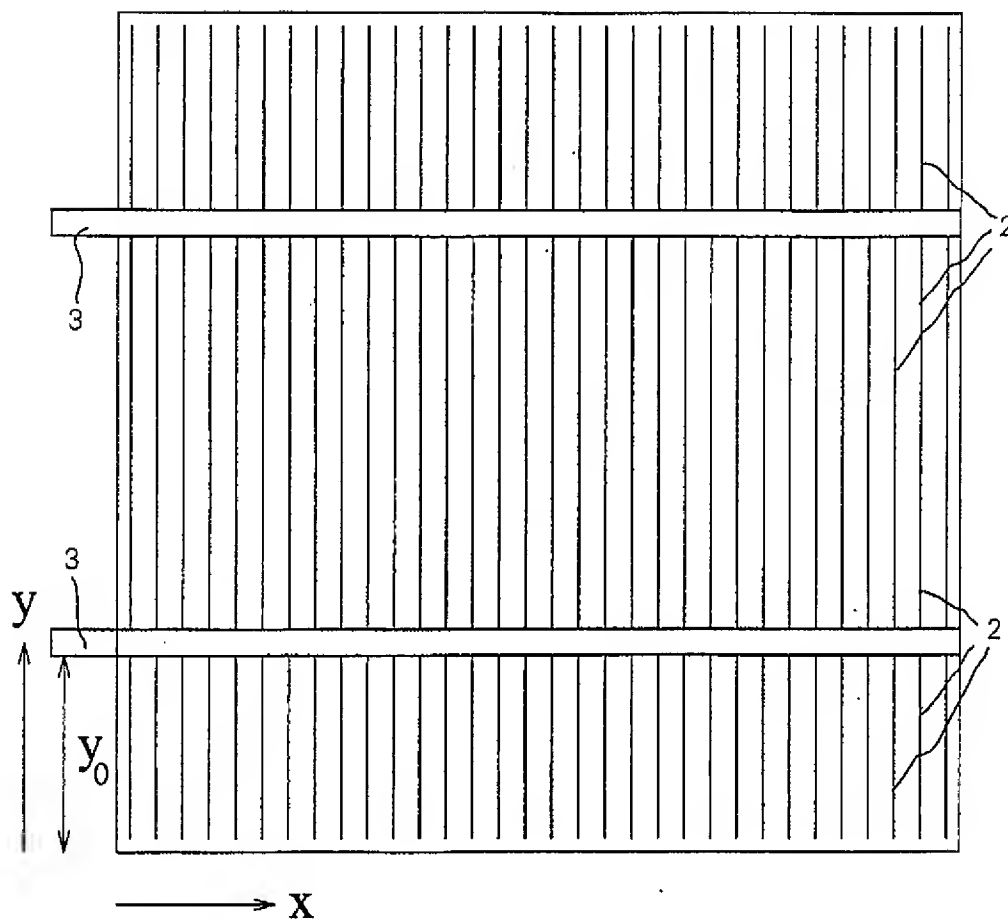


Fig. 1

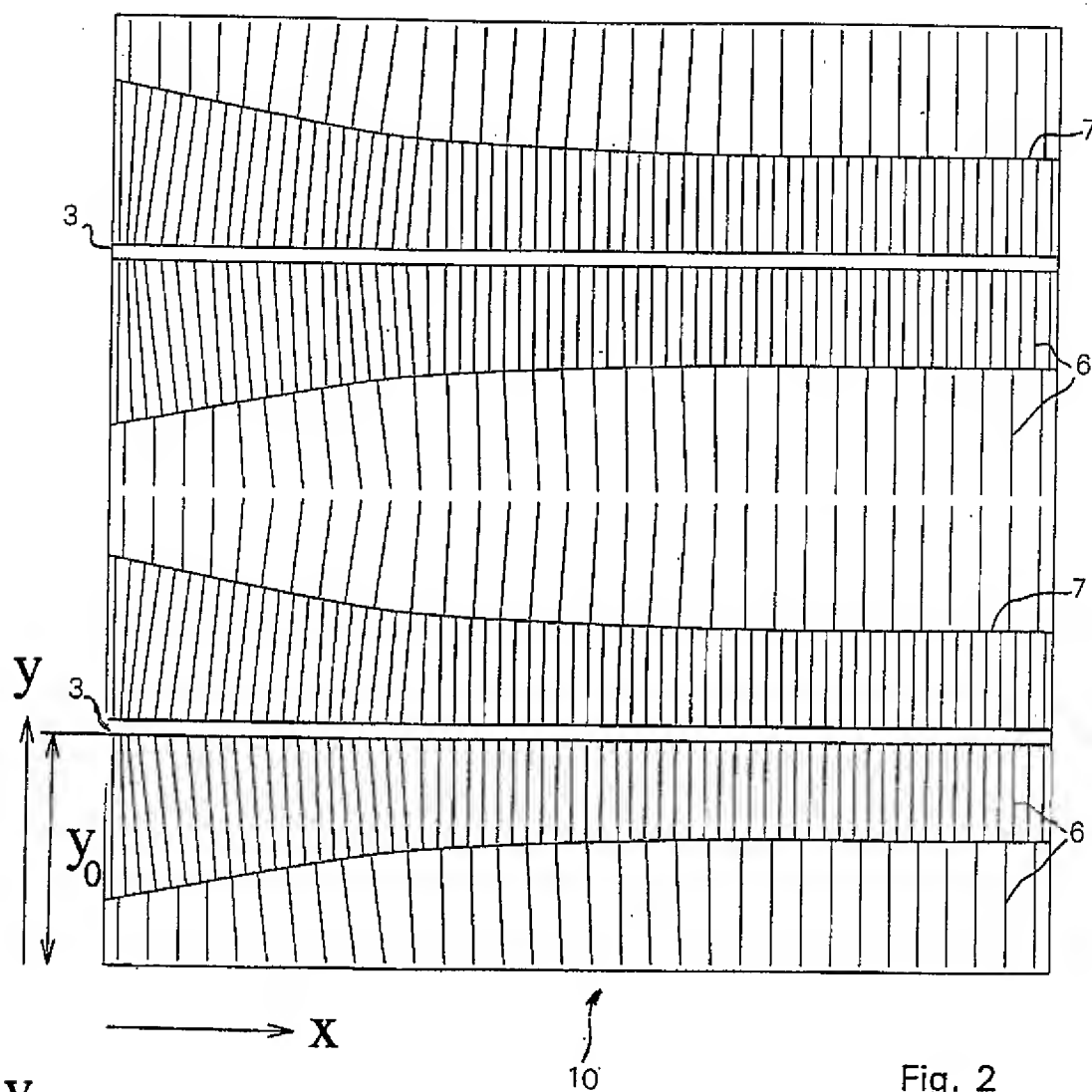


Fig. 2

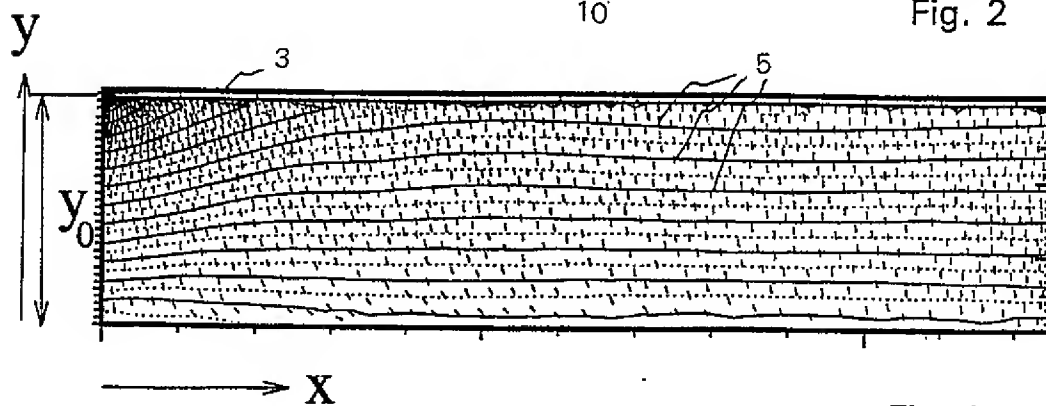


Fig. 3

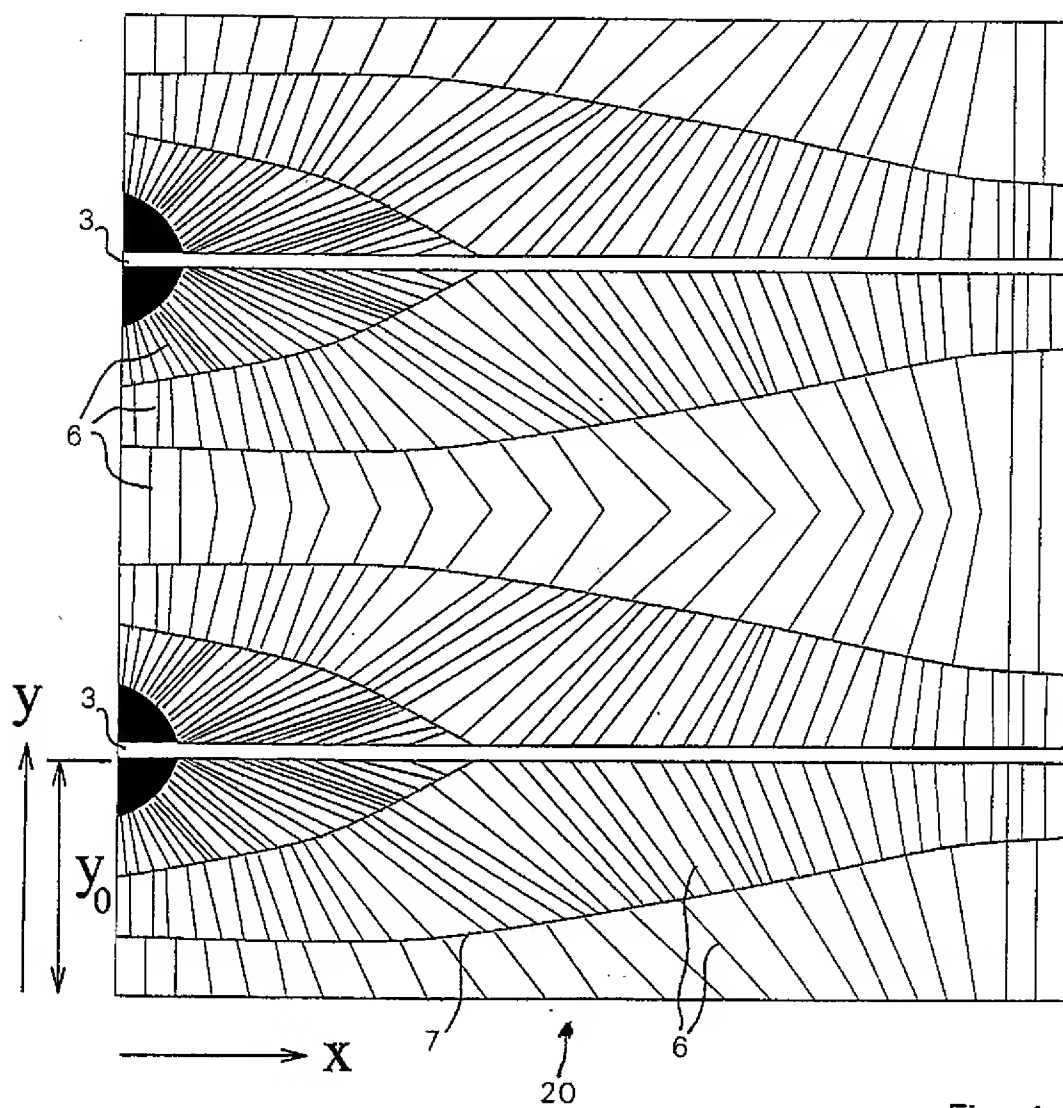


Fig. 4

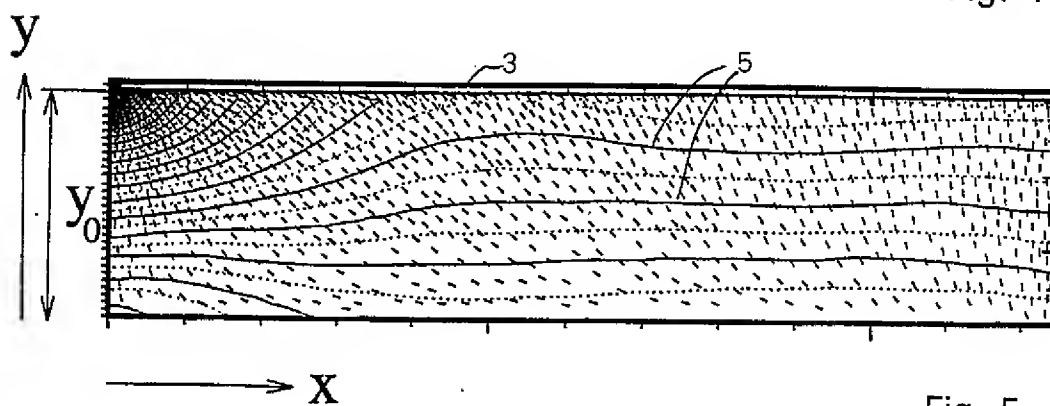


Fig. 5

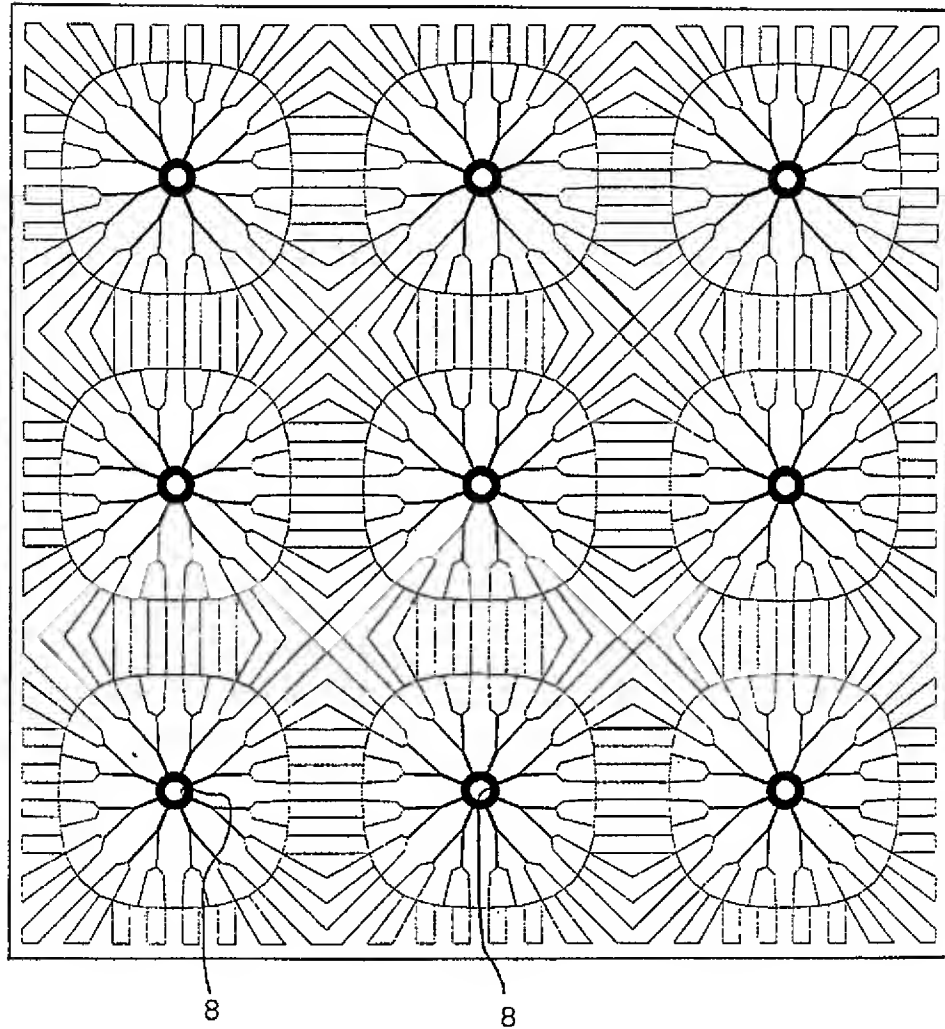


Fig. 6

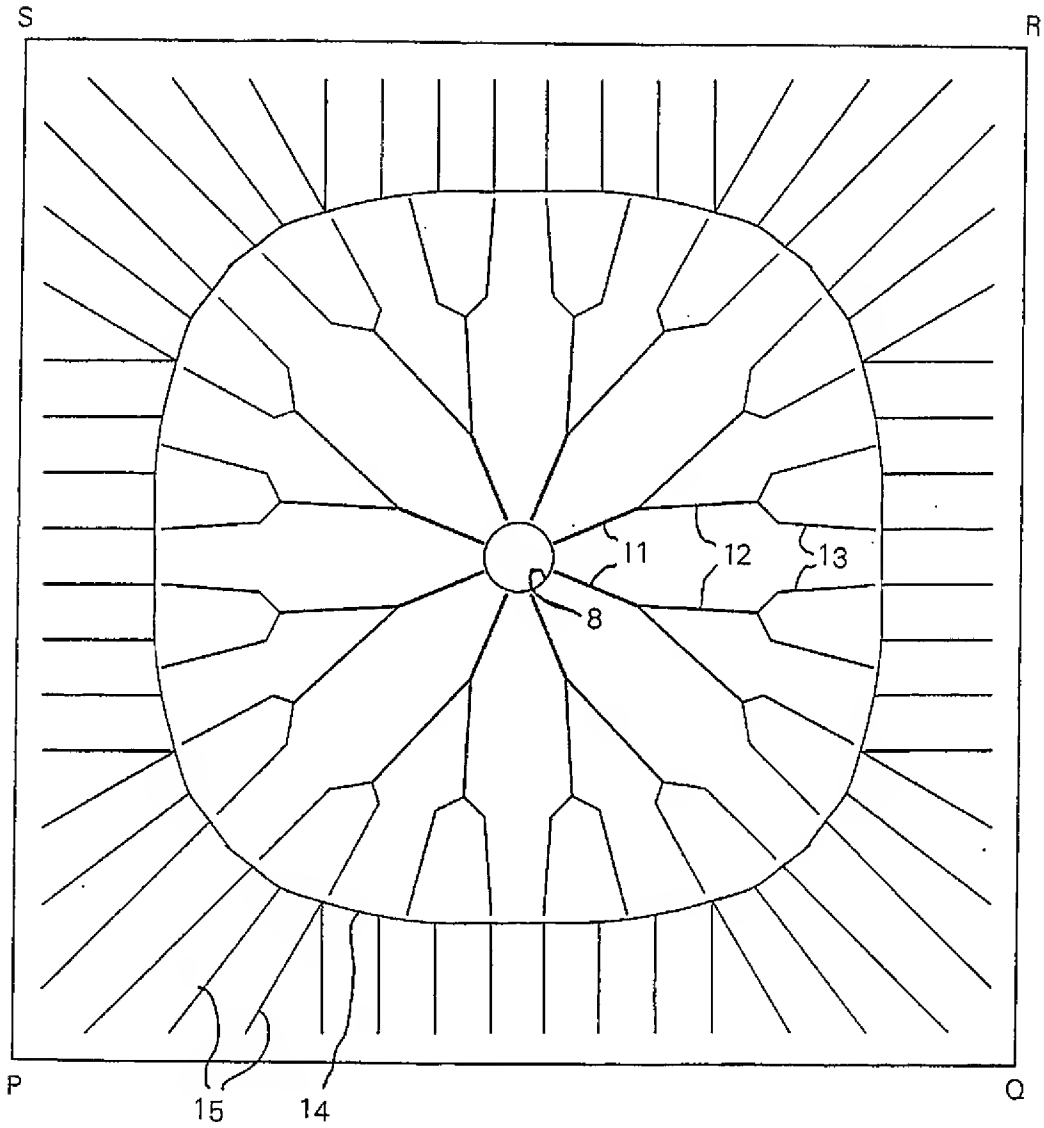


Fig. 7

6/7

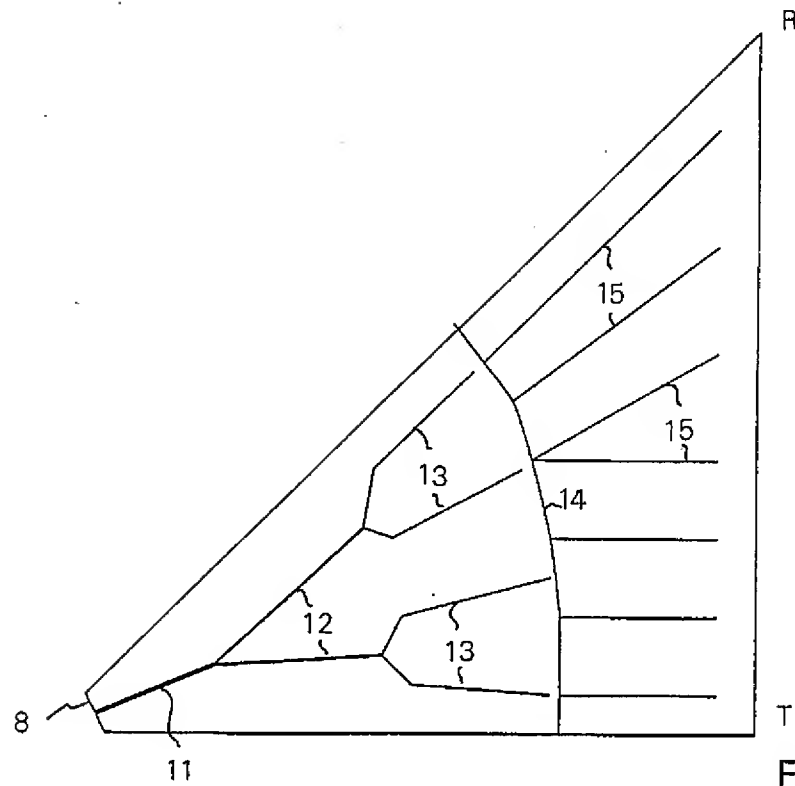


Fig. 8

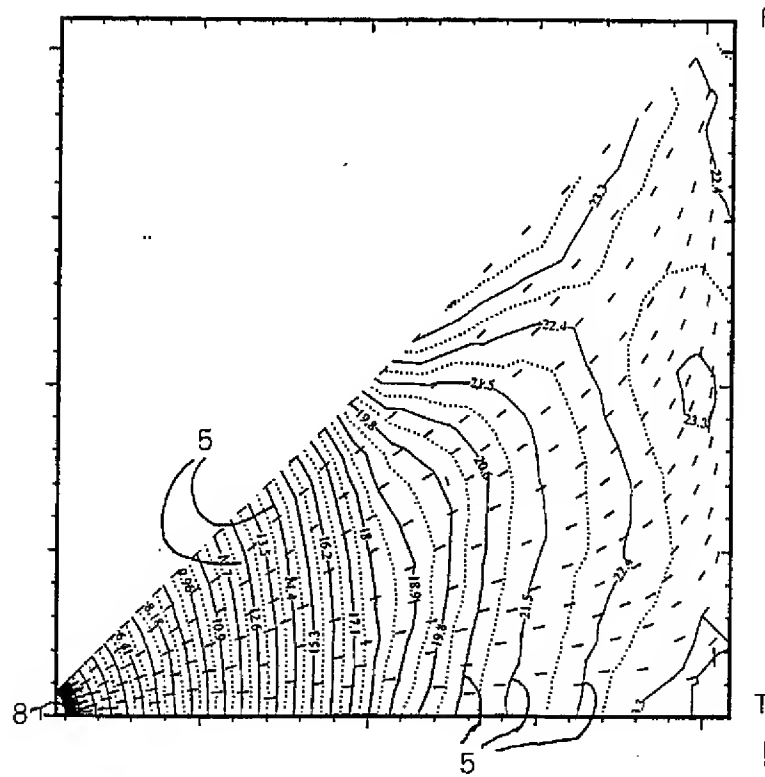


Fig. 9

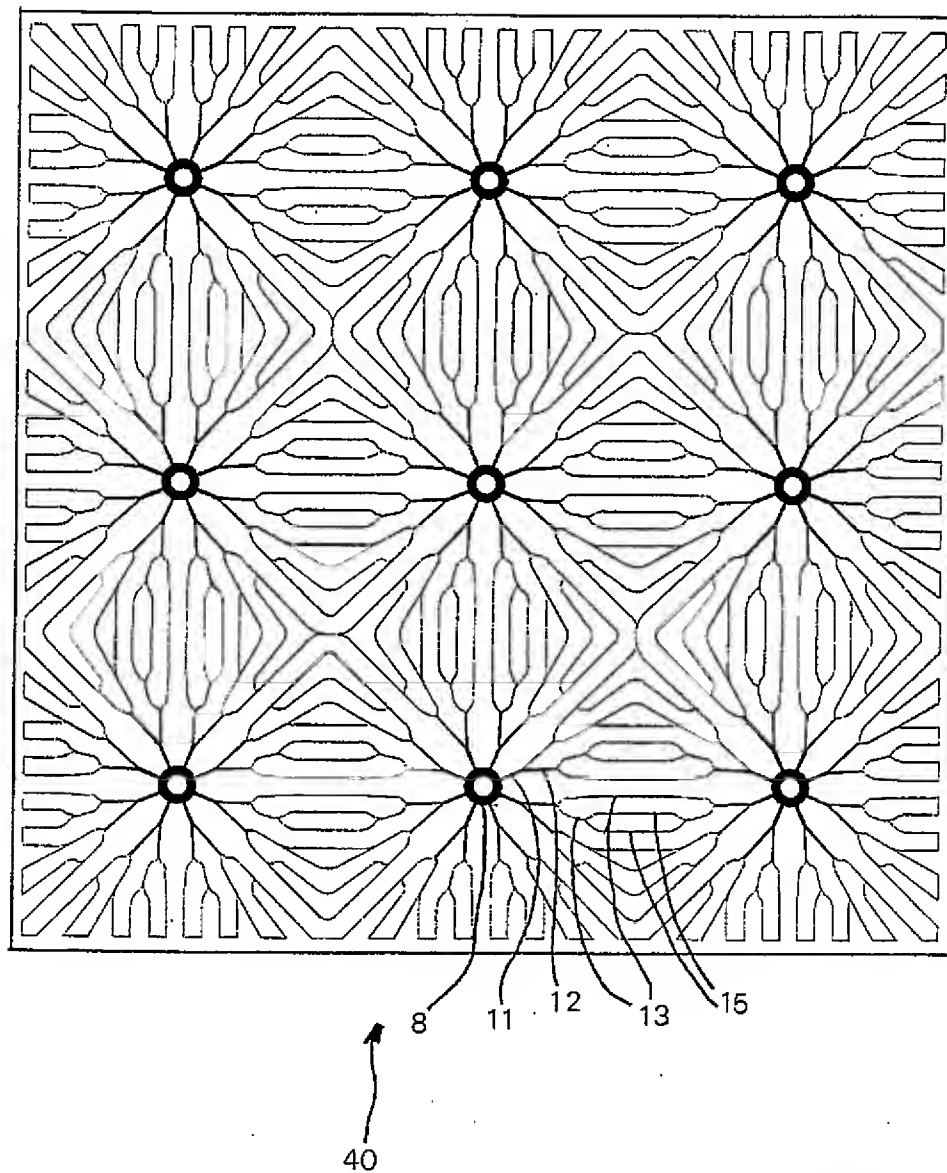


Fig. 10

INTERNATIONAL SEARCH REPORT

Int. Serial Application No.

PCT/NL 99/00708

A. CLASSIFICATION OF SUBJECT MATTER
IPC 7 H01L31/0224

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

IPC 7 H01L

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	<p>BURGERS, A.R.: "Optimizing metalization patterns for yearly yield"</p> <p>1997 26TH IEEE PHOTOVOLTAIC SPECIALISTS CONFERENCE, 30 September 1997 (1997-09-30) - 3 October 1997 (1997-10-03), pages 219-222, XP002109970</p> <p>Anaheim, CA</p> <p>page 219, column 1, line 1 - page 220, column 2, line 16</p> <p style="text-align: center;">— — — — — — / —</p>	1

☒ Further documents are listed in the continuation of box C.☒ Patent family members are listed in annex.

* Special categories of cited documents:

- "A" document defining the general state of the art which is not considered to be of particular relevance
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- "P" document published prior to the international filing date but later than the priority date claimed

- "T" later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention
- "X" document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone
- "Y" document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art
- "Z" document member of the same patent family

Date of the actual completion of the international search

17 February 2000

Date of mailing of the international search report

24/02/2000

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Acco, S

INTERNATIONAL SEARCH REPORT

Int. Application No.
PCT/NL 99/00708

C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	<p>NUBILE P ET AL: "A CONTRIBUTION TO THE OPTIMIZATION OF FRONT-CONTACT GRID PATTERNS FRO SOLAR CELLS" SOLID STATE ELECTRONICS, vol. 37, no. 1, 1 January 1994 (1994-01-01), pages 220-222, XP000453725 ISSN: 0038-1101 abstract page 221, column 1, paragraph 4 -column 2, paragraph 1</p>	1
X	<p>DESALVO G C ET AL: "AN OPTIMIZED TOP CONTACT DESIGN FOR SOLAR CELL CONCENTRATORS" PHOTOVOLTAIC SPECIALISTS CONFERENCE, LAS VEGAS, OCT. 21 - 25, 1985, vol. 1, no. CONF. 18, 21 October 1985 (1985-10-21), pages 435-440, XP000132027 INSTITUTE OF ELECTRICAL AND ELECTRONICS ENGINEERS page 435; figures 9-12</p>	1
A	<p>JENKINS P ET AL: "INCREASED EFFICIENCY WITH SURFACE TEXTURING IN ITO/INP SOLAR CELLS" PROCEEDINGS OF THE INTERNATIONAL CONFERENCE ON INDIUM PHOSPHIDE AND RELATED MATERIALS, NEWPORT, APR. 21 - 24, 1992, no. CONF. 4, 21 April 1992 (1992-04-21), pages 186-189, XP000341256 INSTITUTE OF ELECTRICAL AND ELECTRONICS ENGINEERS ISBN: 0-7803-0522-1 page 187, column 1, line 20 - line 28; figures 1-3</p>	1-3
A	<p>WO 89 05521 A (SPECTROLAB INC) 15 June 1989 (1989-06-15) page 5, line 22 -page 6, line 9; figures 1,2</p>	1

INTERNATIONAL SEARCH REPORT

Information on patent family members

Int. Serial Application No

PCT/NL 99/00708

Patent document cited in search report	Publication date	Patent family member(s)	Publication date
WO 8905521 A	15-06-1989	NONE	